IN THE UNITED SPACES PATENT AND TRADEMARK OFFICE

Applicant(s): UENO et al.

Serial No.: 10/779,658

Filed: February 18, 2004

Title: SEMICONDUCTOR PRESSURE

SENSOR DEVICE

Commissioner for Patents Alexandria, VA 22313-1450 Atty. Dkt.: 01-559-RCE

Group Art Unit: 2814

Examiner: Unknown

Date: November 7, 2006

SUPPLEMENTAL INFORMATION DISCLOSURE STATEMENT

Sir:

Pursuant to 37 C.F.R. §1.56, the reference(s) listed on the attached Form PTO-1449 is/are being brought to the attention of the Examiner without any admission that it/they constitute(s) statutory prior art, or without any admission that it/they contain(s) subject matter that anticipates the invention or renders the invention obvious to a person of ordinary skill in the art.

Further, pursuant to 37 C.F.R. §1.97(e), the undersigned hereby certifies that each listed reference was first cited in a Communication (copy and English translation enclosed) from a foreign patent office in connection with a counterpart foreign application not more than three months prior to the filing of this statement.

Although no fees are believed to be due at this time, it is respectfully requested that any such fees be charged to Deposit Account 50-1147. Also, the Examiner is requested to initial the attached PTO Form-1449 and to return a copy of same to the undersigned attorney as proof that the listed reference(s) has/have been considered and made of record.

Respectfully submitted,

James E. Barlow Reg. No. 32,377

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* PATENT APPLICATION

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FORM PTO-14490	ATTY. DKT NO.	01-559-RCE	SER. NO.	10/779,658	
NOV 0 7 2006 - W	APPLICANT	UENO et al.			
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REFERENCE DESIGNATION U.S. PATENT DOCUMENTS

EXAMINER INITIAL	DOCUMENT NUMBER	DATE	NAME	CLASS	SUB CLASS
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FOREIGN PATENT DOCUMENTS

TRANSLATION

T						I	ANSLATION		
	DOCUMENT NUMBER	DATE	COUNTRY	NAME	CLASS	SUB CLASS	YES	NO Eng.	
	JP-A-09-119875	5/6/97	JAPAN						Abstract
	JP-A-11-194060	7/21/99	JAPAN						X
	JP-A-07-335684	12/22/95	JAPAN				ı		X
	JP-A-10-270485	10/9/98	JAPAN						Х

* Full English text is available in machine-translated form in JPO (Japanese Patent Office) English language web site at http://www1.ipdl.jpo.go.jp/PA1/cgi-bin/PA1INDEX.

OTHER REFERENCES (including Author, Title, Date, Pertinent Pages, etc.)

Notice of Reason for Rejection from Japanese Patent Office issued on Octo 2006 for the corresponding Japanese patent application No. 2003-050933 (a and English translation thereof)				
EXAMINER	DATE CONSIDERED			

Rev. 10/94 (Form 3.05)